## TRANSMITTAL FORM

Attorney Docket No. P3P2000078US 2369NP

In re the application Yuji Okuta P

Serial No: 10/018,708 JUL 0 5 2005

Filed: December 13, 2001

Confirmation No: 1643

Group Art Unit: 3723

Examiner: Wilson, Lee D.

For: Table of Wafer Polishing Apparatus, Method for Polishing Semiconductor Wafer, and Method for Manufacturing Semiconductor Wafer										
ENCLOSURES (check all that apply)										
	Amendment/Reply				Assignment and Recordation Cover Sheet			After Allowance Communication to Group		
	After Final				Part B-Issue Fee Transmittal			Notice of Appeal		
	Information disclosure statement				Letter to Draftsman			Appeal Brief		
	Form 1449				Drawings			Status Letter		
	(X) Co	(X) Copies of References			Petition			Postcard		
	Extension of Time Request *				Fee Address Indica	tion Form		Other Enclosure(s) (please identify below):		
	Express Abai	ndon	nment		Terminal Disclaimer					
	Certified Copy of Priority Doc				Power of Attorney and Revocation of Prior Powers					
	Response to Incomplete Appln				Change of Correspondence Address					
	Response to Missing Parts				*Extension of Term: Pursuant to 37 CFR 1.136, Applicant petitions the Commissioner to extend the time for response for xxxxxx month(s),					
	Executed Declaration by Inventor(s)  Executed Declaration by from to .							.(0),		
CLAIMS										
FOR Claims Remain				Highest # of Claims Previously Paid For	Extra Claims		RATE	FEE		
Total	Claims		37		42	0		\$ 50.00	\$ 0.00	
Indep	endent Claims		_ 2		3	0		\$200.00	\$ 0.00	
Total Fees   \$ 0.00  METHOD OF PAYMENT										
Check no in the amount of \$ is enclosed for payment of fees.										
	Charge \$ to Deposit Account No (Account Holder Name) for payment of fees.									
Charge any additional fees or credit any overpayment to Deposit Account No. <u>02-2120</u> (Sawyer Law Group)										
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT										
Attorney Name Joseph A. Sawyer, Jr., Reg. No. 30, 801										
Signature Day a Am										
Date July 1, 2005										
CERTIFICATE OF MAILING										
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Step AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on July 1, 2005										
Type or printed name										
Signature Xrena / Sixoto, a										

Attorney Docket: 2369NP

## CERTIFICATE OF MAIL

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 1, 2005

Irena Nikolova

JUL 0 5 2005 B

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Yuji Okuda

Confirmation No.: 1643

Serial No: 10/018,708

Group Art Unit: 3723

Filed: April 15, 2002

Examiner: Wilson, Lee D

For:

TABLE OF WAFER POLISHING APPARATUS, METHOD FOR POLISHING

SEMICONDUCTOR WAFER, AND METHOD FOR MANUFACTURING

SEMICONDUCTOR WAFER

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT**

Sir:

In response to the Final Office Action dated March 31, 2005, please amend the aboveidentified application in the following manner:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.